

Edge-TCT studies of heavily irradiated strip detectors

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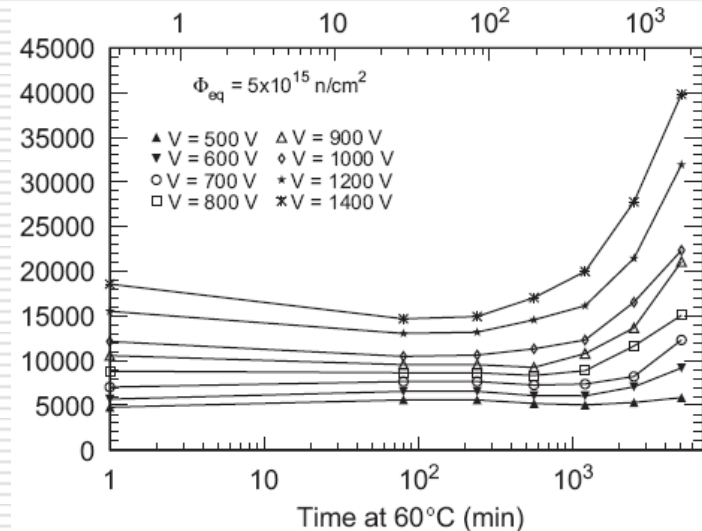
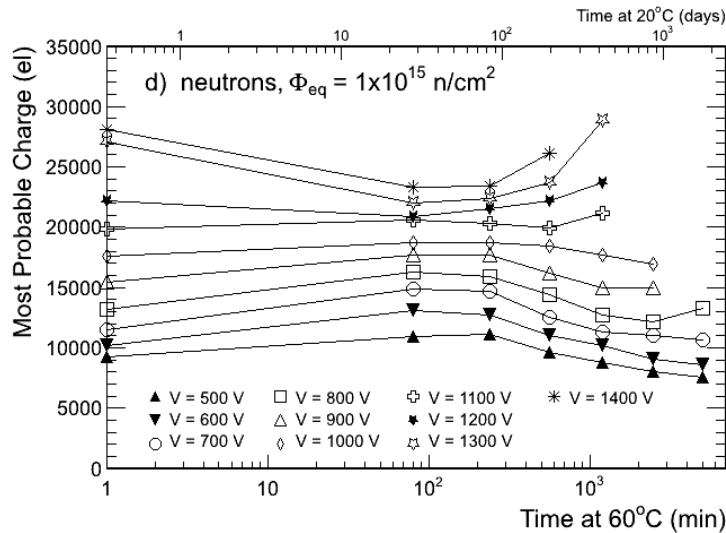
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Outline

- Motivation
- Samples, irradiations, annealing procedure
- Experimental setup, extraction of charge collection and velocity profiles
- Results - evaluation of induced signals, CC, velocity and I-V profiles, influence of annealing
- Conclusions

Motivation



Taken from: I. Mandić et al., NIM A 629 (2011) 101-105

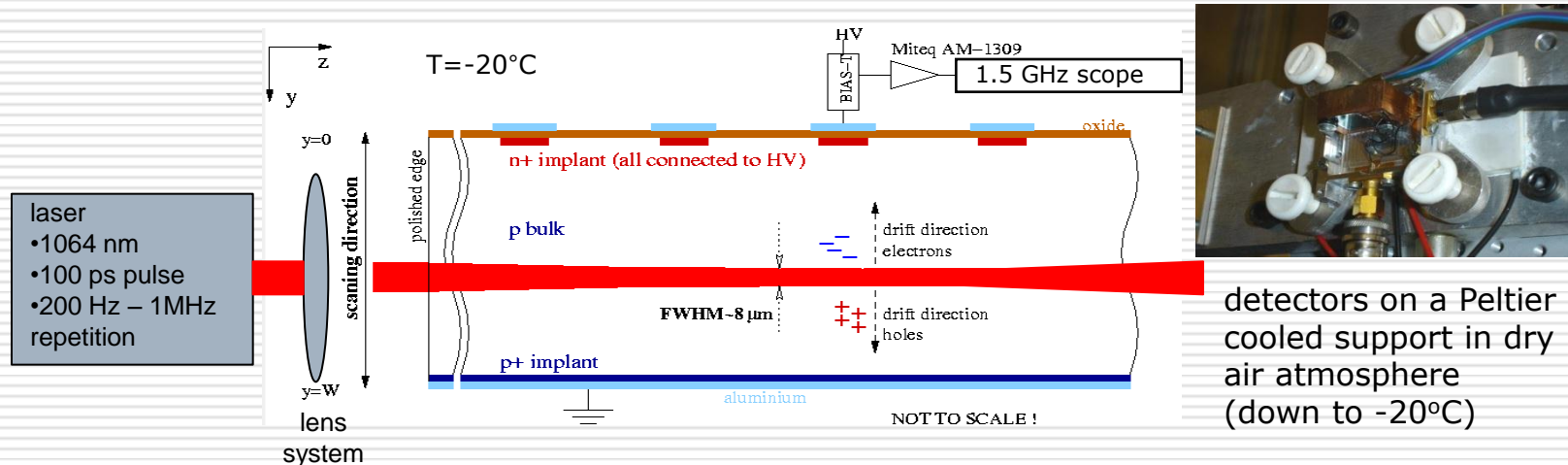
- Charge multiplication effects are observed in highly irradiated FZ p-type strip detectors after long annealing times. [Liverpool, Freiburg, IJS]
- The idea is to examine where/when impact ionization takes place inside the detector and how multiplication affects the total charge collected.

Samples, irradiation and the annealing procedure

Sample	Fluence	Annealing
1) HPK (ATLAS-07 run) 1x1 cm ² , 300 μm thick Material/type: FZ, p-type initial $V_{fd} \sim 190$ V	$\Phi_{eq} = 1 \cdot 10^{16}$ cm ⁻² (Fluence history: 1,2,5 · 10 ¹⁵ cm ⁻² with annealing up to 80min.)	Sequential steps (0,10,20,40,80,160,320, 640,1280,2560,5120 min) at 60°C up to a cumulative time of 10240 min.
2) MPP/HLL (provided by MPI) 1x1.2 cm ² , 150 μm thick, bonded on low resistivity handle wafer Material/type: FZ, p-type initial $V_{fd} \sim 82$ V	$\Phi_{eq} = 5 \cdot 10^{15}$ cm ⁻²	Sequential steps at 60°C up to a cumulative time of 20480 min

- ❑ Irradiations performed with 1MeV reactor neutrons at TRIGA (JSI, Ljubljana)
- ❑ At each annealing step, measurements of collected charge and leakage current performed at bias voltages of up to 1000V.
- ❑ Annealing performed with the sample mounted inside the setup
 - ❑ Stable position/laser (the same spot illuminated each time)
 - ❑ Sample temperature stabilized to less than 1°C

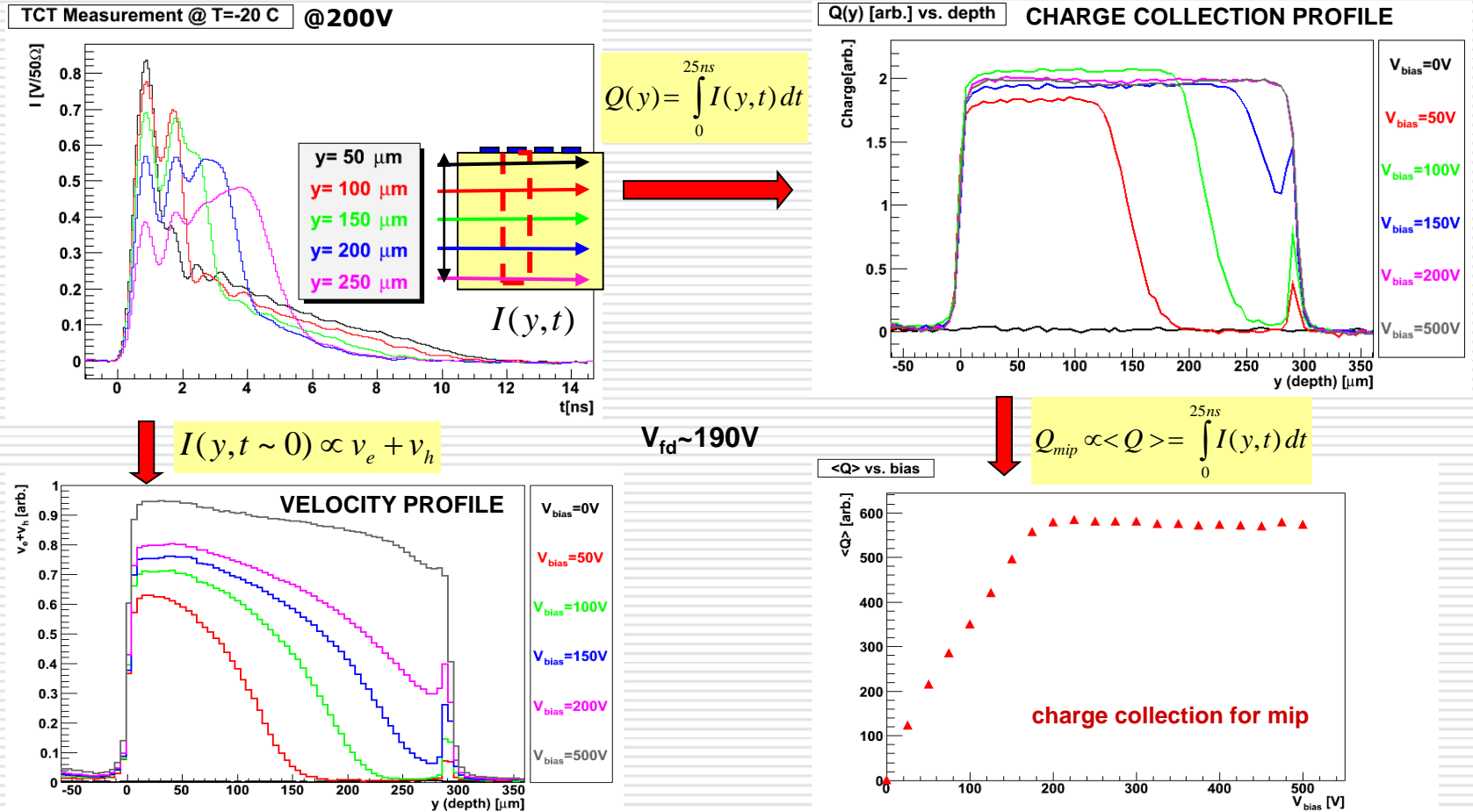
Edge-TCT setup



- Position of e-h generation controlled by 3 sub-micron moving tables (x,y,z)
- The amount of injected charge and frequency can be controlled (laser tune and frequency=200Hz kept constant during these measurements)
- Absolute charge measurements are very difficult to achieve, therefore arbitrary units used for collected charge.

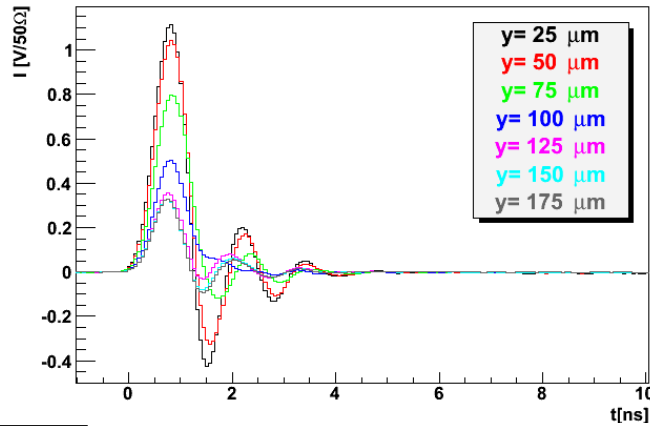
Charge collection and velocity profiles

HPK, non-irradiated

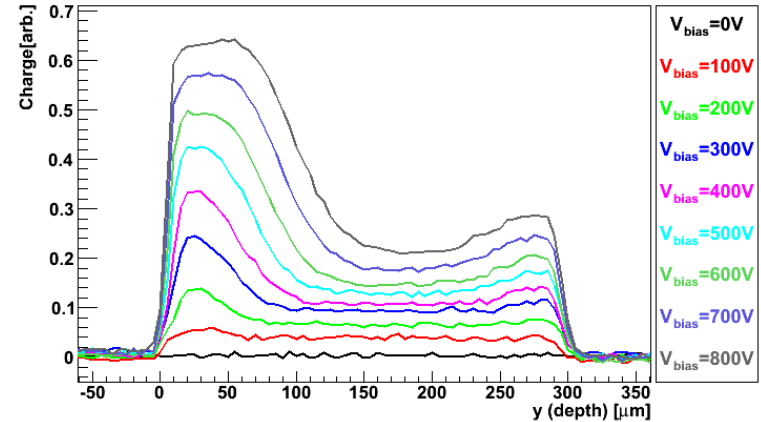


HPK – $\Phi_{eq} = 1 \cdot 10^{16}$ n/cm², no annealing

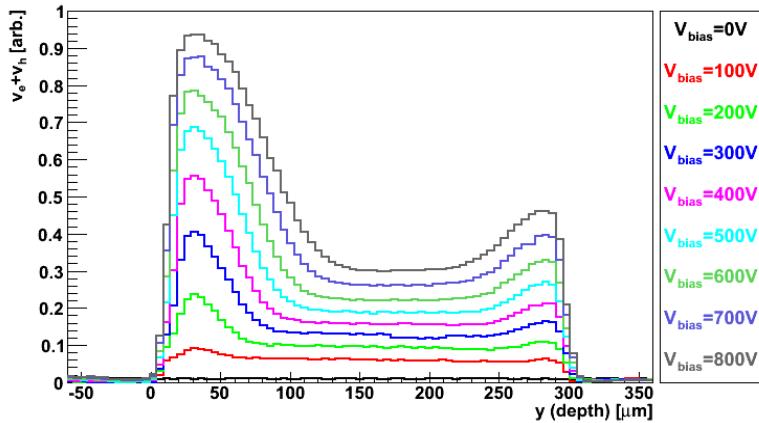
TCT Measurement @ T=-20 C @800V



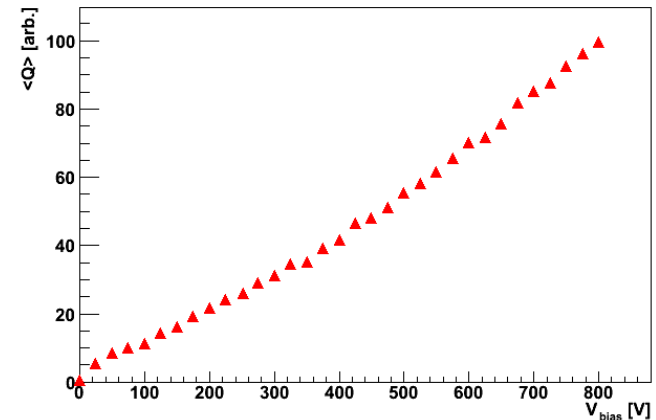
Q(y) [arb.] vs. depth, $t_{ann} = 0min$



velocity

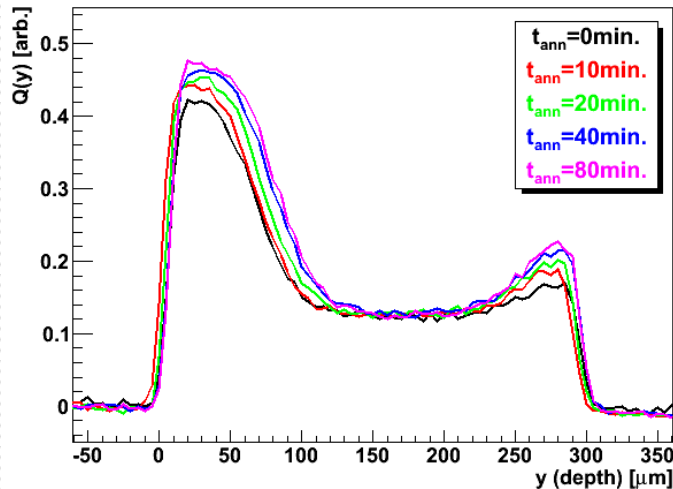


$\langle Q \rangle$ vs. bias

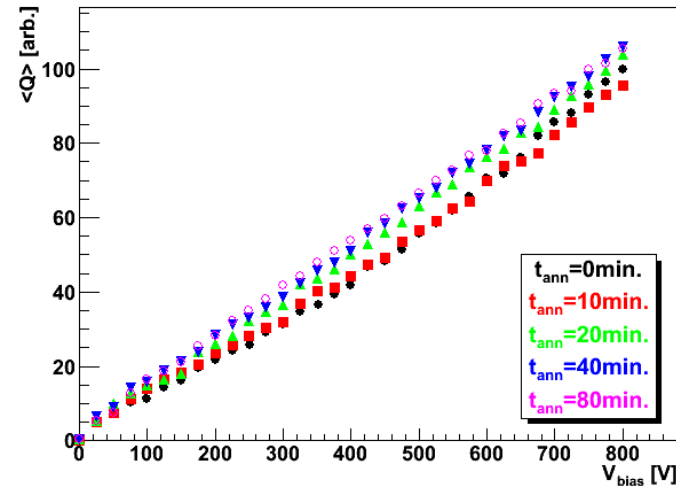


HPK – $\Phi_{eq} = 1 \cdot 10^{16}$ n/cm², $t_{ann} = 0 \div 80$ min

Q(y) [arb.] @500V, $t_{ann} = 0 \div 80$ min.

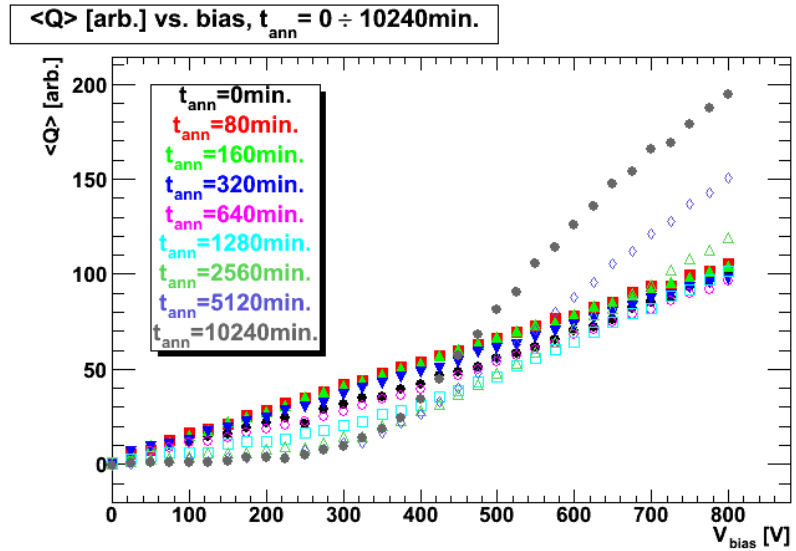
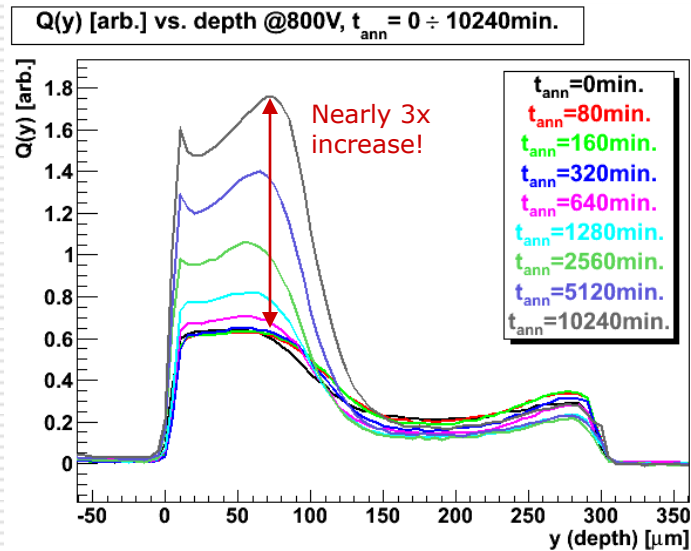


<Q> [arb.] vs. bias, $t_{ann} = 0 \div 80$ min.



- Beneficial annealing (after 80 min at 60^oC) of space charge and trapping times of electrons observed and found for both junctions.
- The annealing effect is not very significant, though it should be noted that annealing was already taking place during previous irradiation steps.

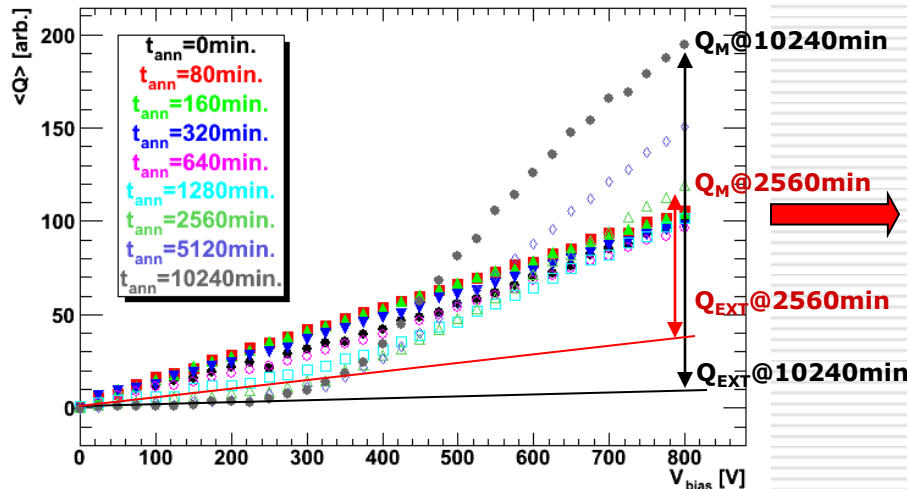
HPK - $\Phi_{eq} = 1 \cdot 10^{16} \text{ n/cm}^2$, $t_{ann} = 0 \div 10240 \text{ min}$



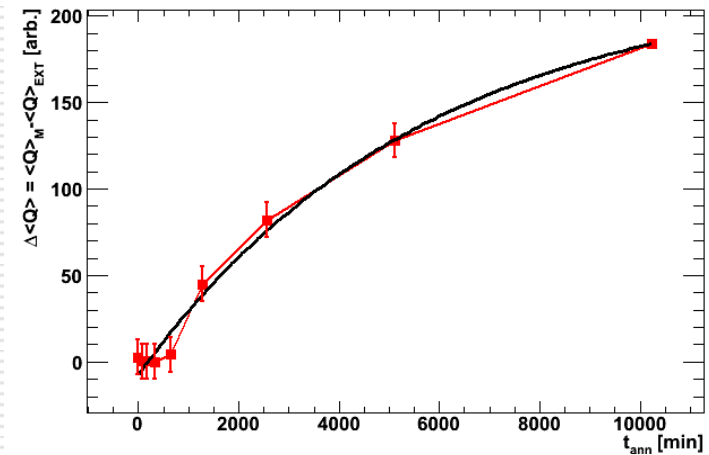
- During long-term annealing, up to a total of 10240 min. at 60°C, a nearly threefold increase in CC in the region near the strips (highest E).
- Increase due to space charge concentration rising near the n^+ -p junction with the annealing, leading to a substantial increase of E ($E > \sim 12 \text{ V}/\mu\text{m}$) where the impact ionization takes place (between 320 and 640 min).
- If the voltage and thus E is not large enough to start impact ionization, CC decreases due to long-term (reverse) annealing.

HPK – $\Phi_{eq} = 1 \cdot 10^{16} \text{ n/cm}^2$, $t_{ann} = 0 \div 10240 \text{ min.}$

$\langle Q \rangle$ [arb.] vs. bias, $t_{ann} = 0 \div 10240 \text{ min.}$



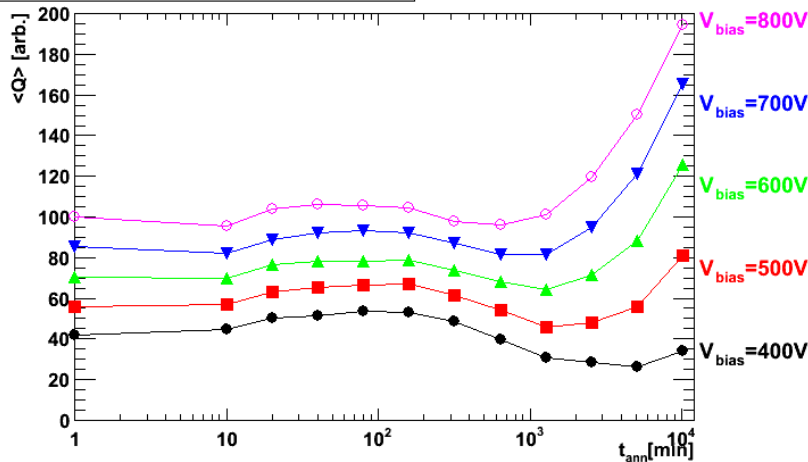
Only an approximate method!



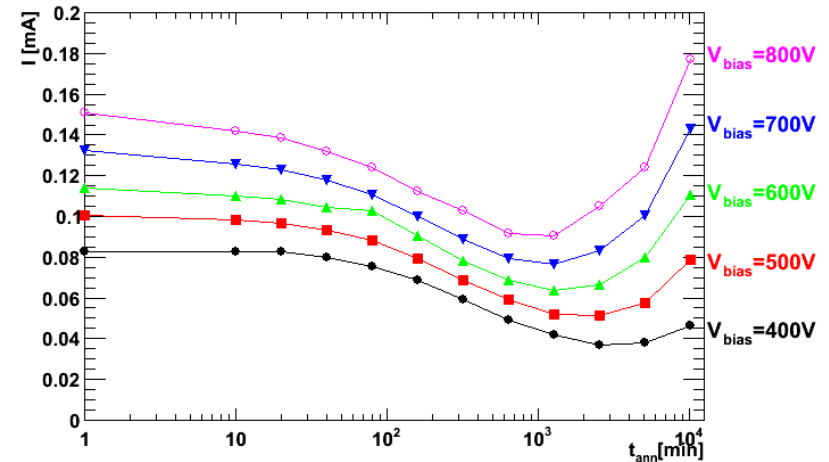
- The contribution of charge multiplication to $CC/\langle Q \rangle$ was estimated by subtracting the measured values of CC at 800 V with extrapolated values from the lower voltage CC curves linear fit to 800 V ($\langle Q \rangle_M - \langle Q \rangle_{EXT}$).
- By plotting the dependence of CC contribution on annealing time and fitting the values with $1 - \exp(-t/\tau_Y)$, a time constant of $3000 \div 5000 \text{ min}$ is obtained.
- Time constants for ΔN_{eff} and $\Delta \langle Q \rangle$ are the same order of magnitude, supporting the assumption that N_{eff} increase causes greater impact ionization.

HPK – $\Phi_{eq} = 1 \cdot 10^{16} \text{ n/cm}^2$, $t_{ann} = 0 \div 10240 \text{ min}$.

$\langle Q \rangle$ [arb.] vs. t_{ann} , $t_{ann} = 0 \div 10240 \text{ min}$.



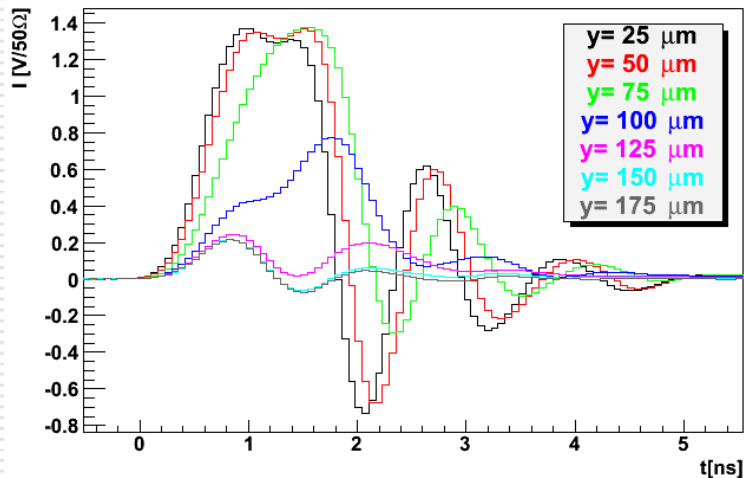
I vs. t_{ann} , $t_{ann} = 0 \div 10240 \text{ min}$.



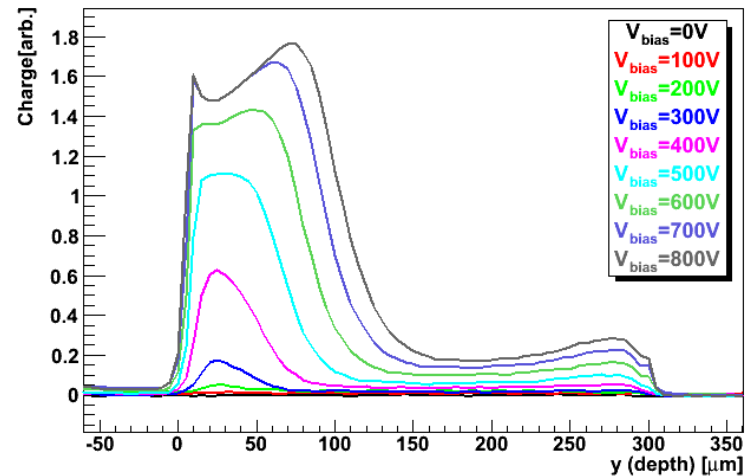
- The initial beneficial effect of annealing clearly noticed up to $\sim 100 \text{ min}$, later drop due to long term annealing effects, until the onset of multiplication.
- Charge multiplication noticed even at 400V after the final annealing step!
- Strong correlation with the leakage current – beneficial effect until the onset of multiplication at 1000min, following the pattern of increasing CC.
- Charge multiplication is also clearly recognized in the induced current pulse shapes measured at different depths.

HPK - $\Phi_{eq} = 1 \cdot 10^{16}$ n/cm², $t_{ann} = 0 \div 10240$ min.

TCT Measurement @ T=-20 C @800V

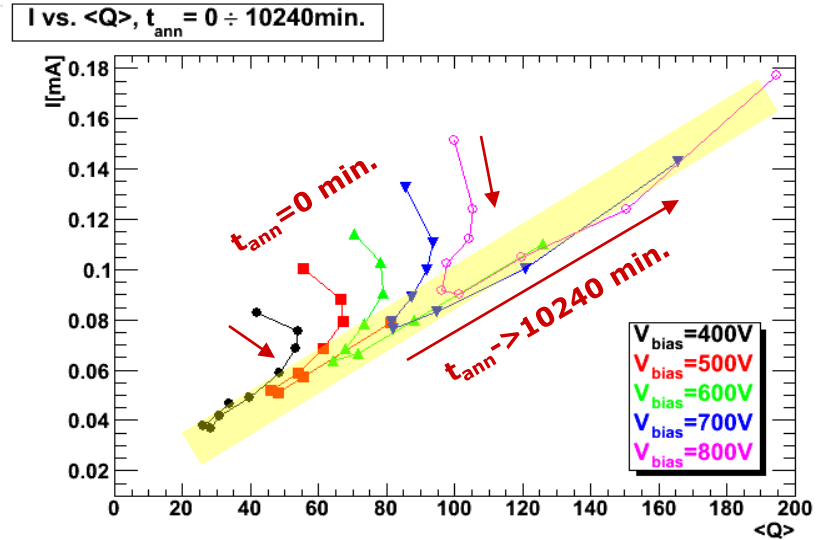
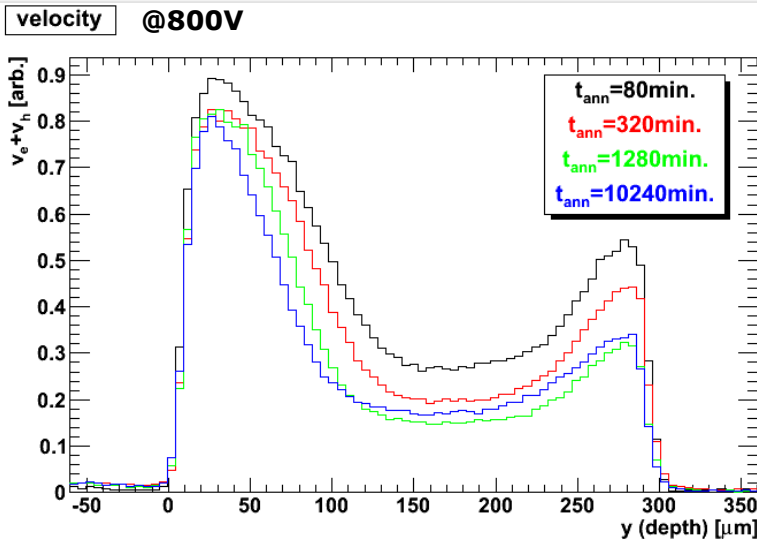


Q(y) [arb.] vs. depth, $t_{ann} = 10240$ min



- The first peak, associated with the initial drift of primarily generated carriers (from the laser) widens up to a point where the second peak, coming from the multiplied carriers, becomes more apparent and the dominant one.
- This can also be observed in CC profiles for different bias voltages: as the bias increases, E becomes large enough to invoke multiplication over a larger area inside the detector.

HPK - $\Phi_{eq} = 1 \cdot 10^{16} \text{ n/cm}^2$, $t_{ann} = 0 \div 10240 \text{ min.}$

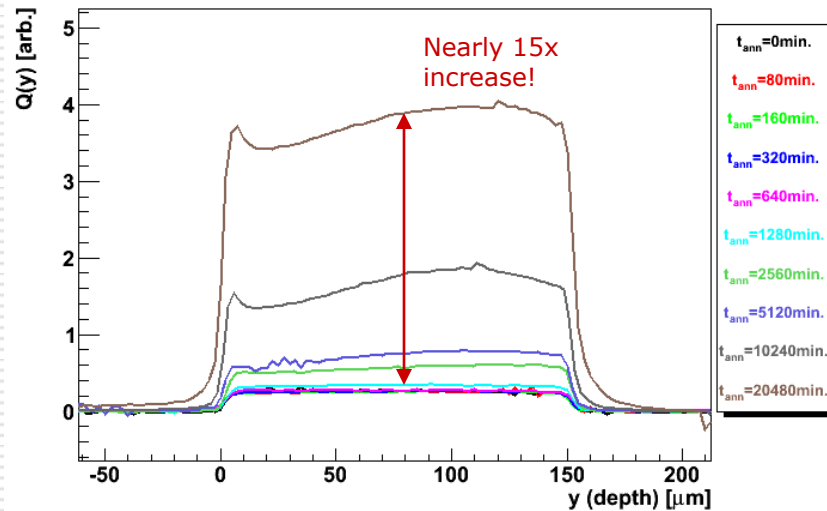


- The velocity profile points to the reduction of the high E region in the detector with annealing time. The drift velocity close to the strips is almost saturated, while in the rest of the detector is smaller for longer annealing times, implying that E close to the strips must increase.
- Confirmation of assumed space charge development with LT annealing.
- The correlation between the current and CC is near linear => thermally generated carriers undergo the same effect.

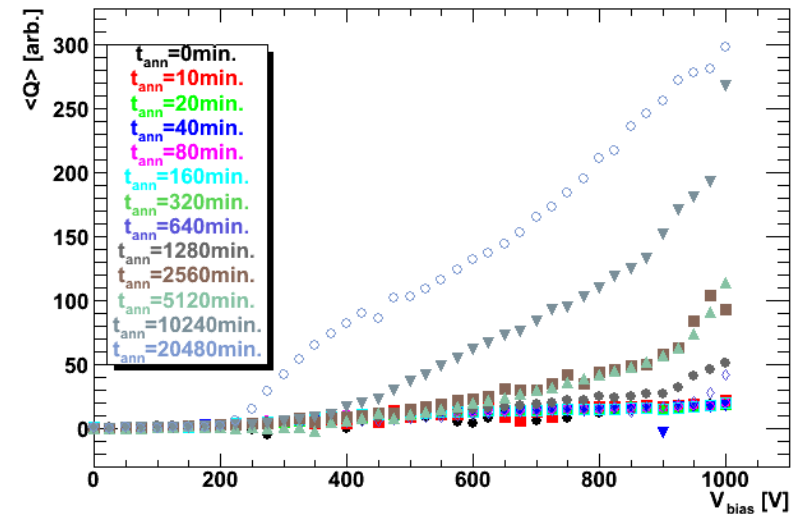
MPP/HLL – $\Phi_{eq} = 5 \cdot 10^{15} \text{ n/cm}^2$, $t_{ann} = 0 \div 20480 \text{ min}$ (150 μm)

Thanks to: Philipp Weigell and A. Macchiolo, MPI

Q(y) [arb.] vs. depth @900V, $t_{ann} = 0 \div 20480 \text{ min}$.



$\langle Q \rangle$ [arb.] vs. bias, $t_{ann} = 0 \div 20480 \text{ min}$.

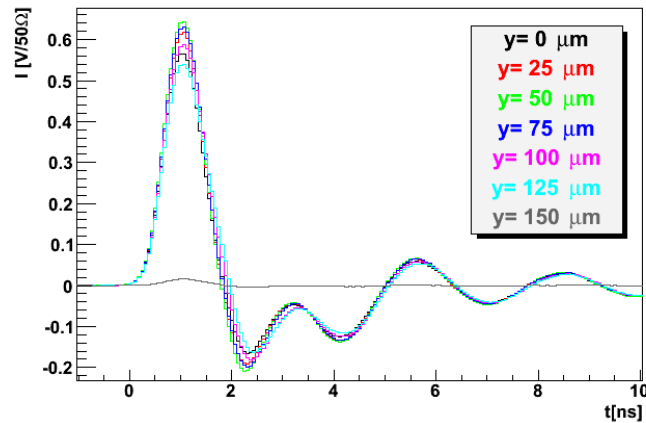


- ❑ Initial $V_{fd} \approx 82 \text{ V}$.
- ❑ Estimated V_{fd} after irradiation and 80min of annealing: $\sim 1500 \text{ V}$.
- ❑ Charge multiplication contribution to CC $\sim 15 \times$ after 20480min! (the detector still under study – currently annealing to 40960min!)
- ❑ Charge multiplication noticed even at 250V after the final annealing step!

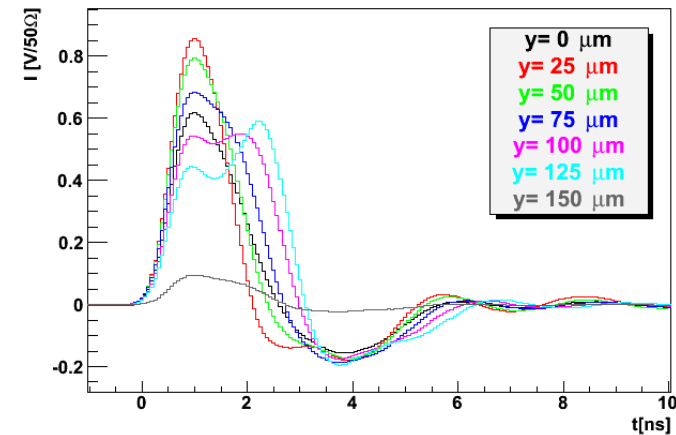
MPP/HLL – $\Phi_{eq} = 5 \cdot 10^{15} \text{ n/cm}^2$, $t_{ann} = 0 \div 20480 \text{ min}$ (150 μm)

Thanks to: Philipp Weigell and A. Macchiolo, MPI

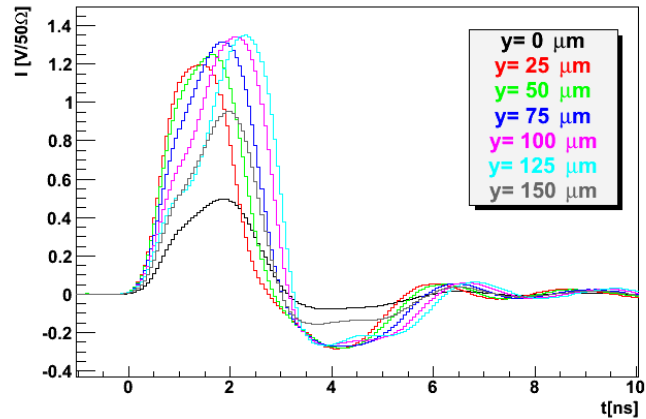
TCT Measurement @ T=-20 C @900V – 80min



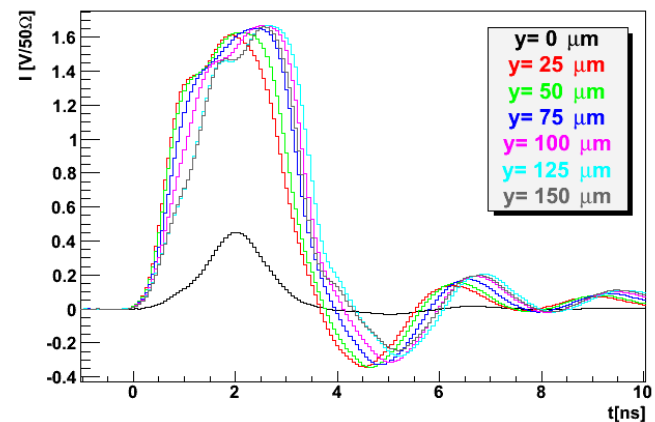
TCT Measurement @ T=-20 C @900V – 5120min



TCT Measurement @ T=-20 C @900V – 10240min



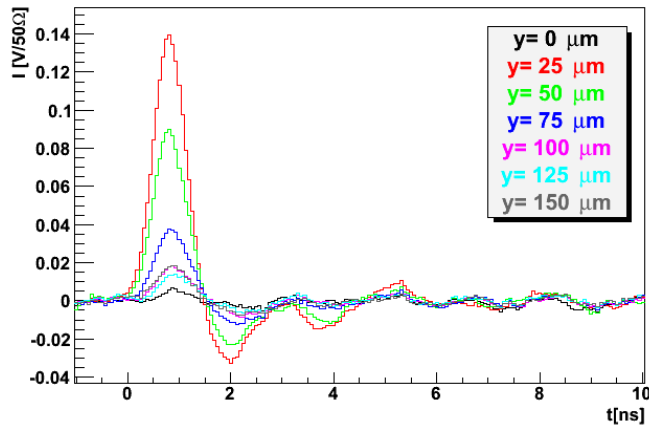
TCT Measurement @ T=-20 C @900V – 20480min



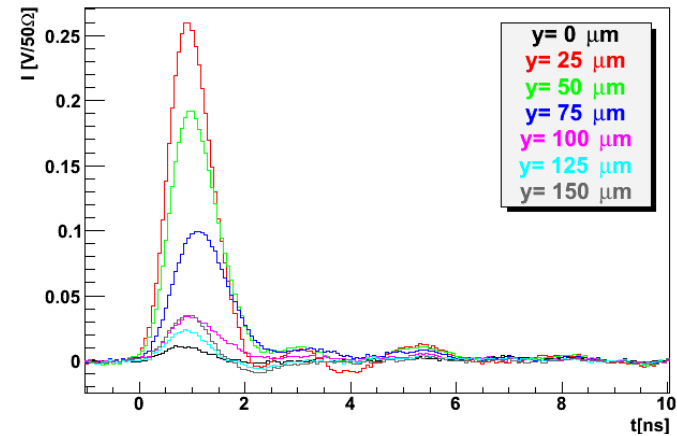
MPP/HLL – $\Phi_{eq} = 5 \cdot 10^{15} \text{ n/cm}^2$, $t_{ann} = 20480 \text{ min}$ (150 μm)

Thanks to: Philipp Weigell and A. Macchiolo, MPI

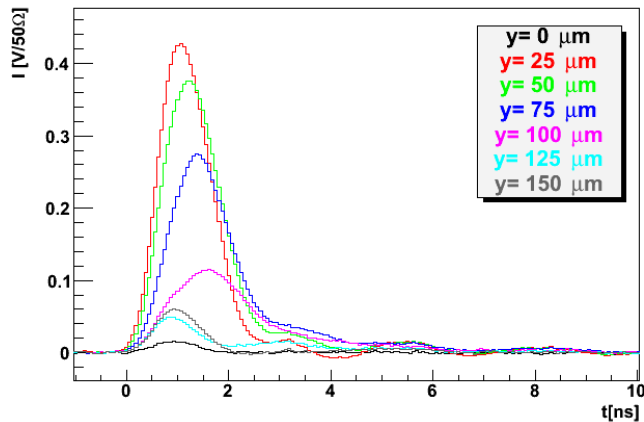
TCT Measurement @ T=-20 C @200V



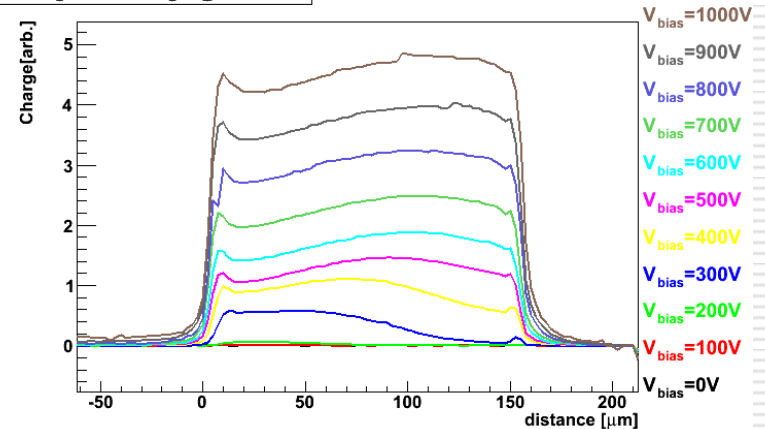
TCT Measurement @ T=-20 C @250V



TCT Measurement @ T=-20 C @300V



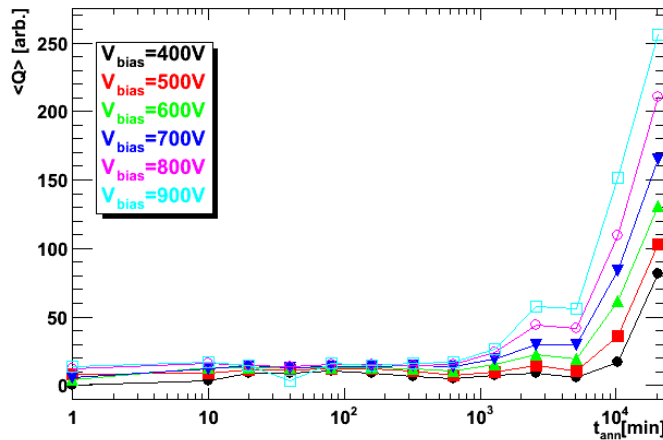
Charge vs. Voltage @ T=-20 C



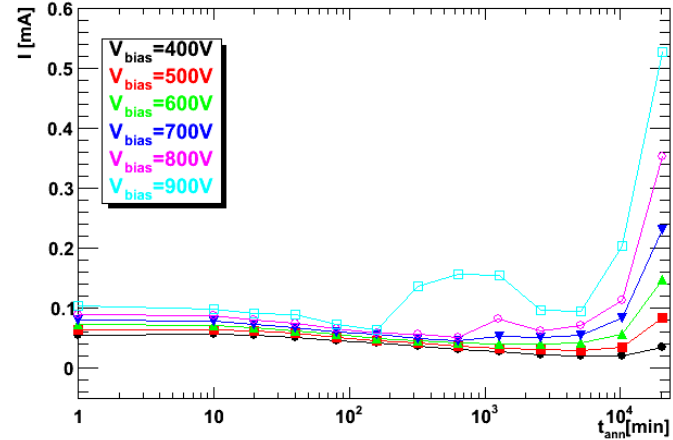
MPP/HLL – $\Phi_{eq} = 5 \cdot 10^{15} \text{ n/cm}^2$, $t_{ann} = 0 \div 20480 \text{ min}$ (150 μm)

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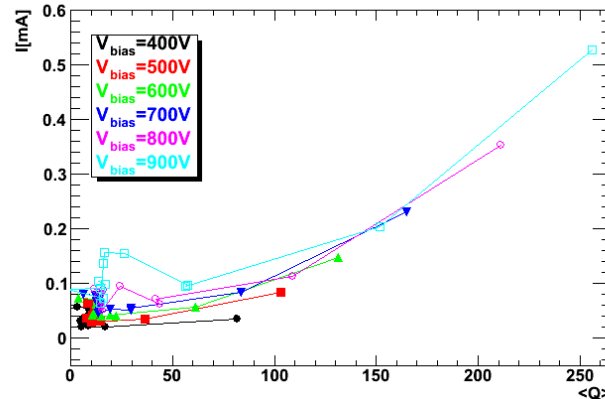
$\langle Q \rangle$ [arb.] vs. t_{ann} , $t_{ann} = 0 \div 20480 \text{ min}$.



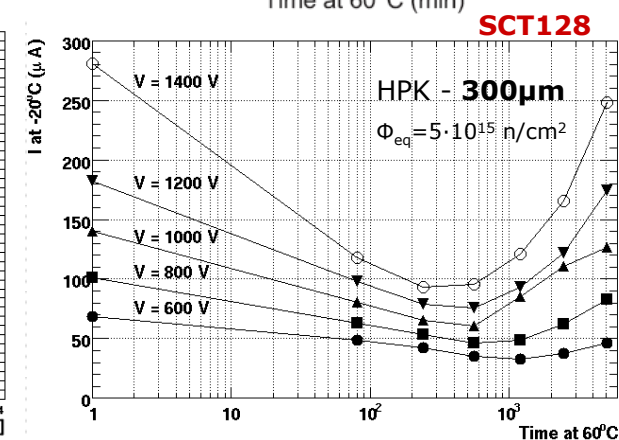
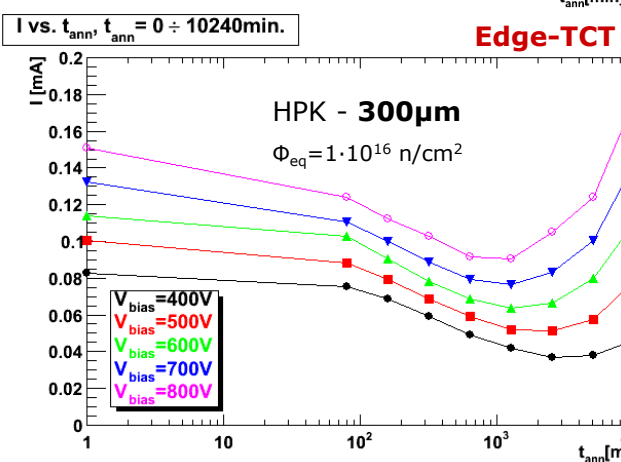
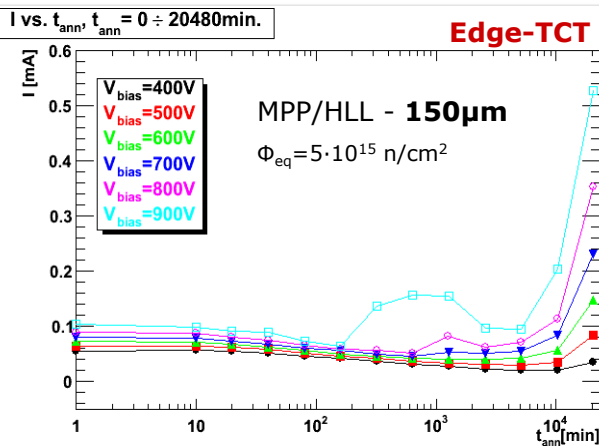
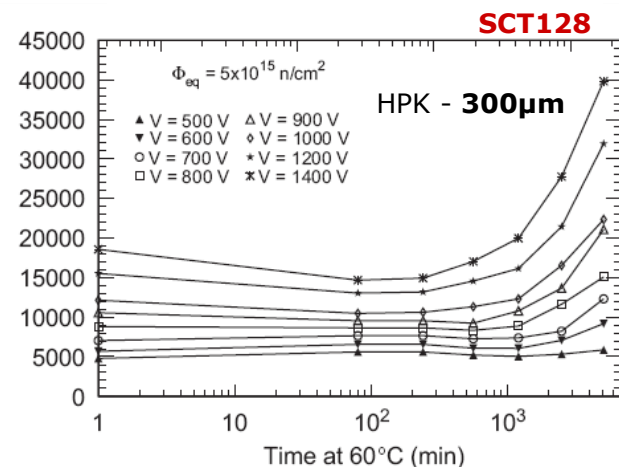
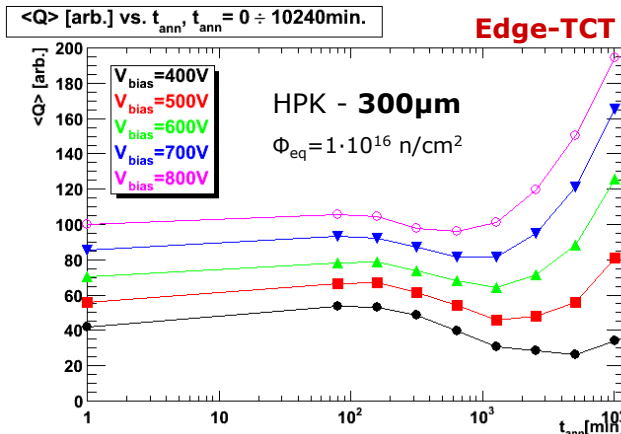
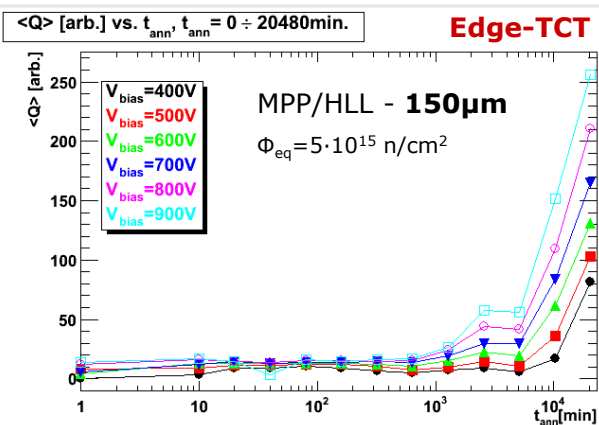
I vs. t_{ann} , $t_{ann} = 0 \div 20480 \text{ min}$.



I vs. $\langle Q \rangle$, $t_{ann} = 0 \div 20480 \text{ min}$.

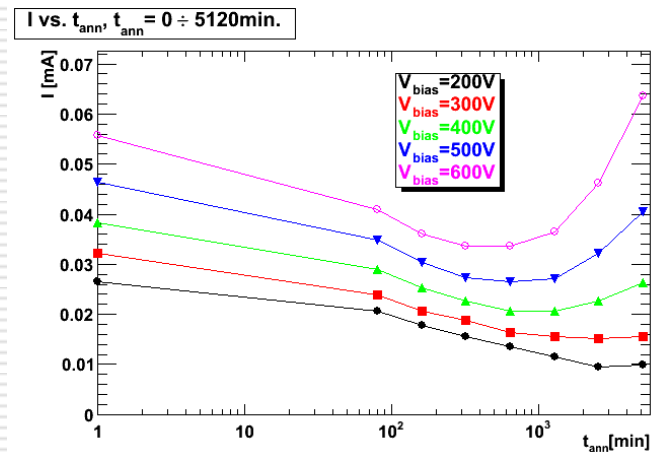
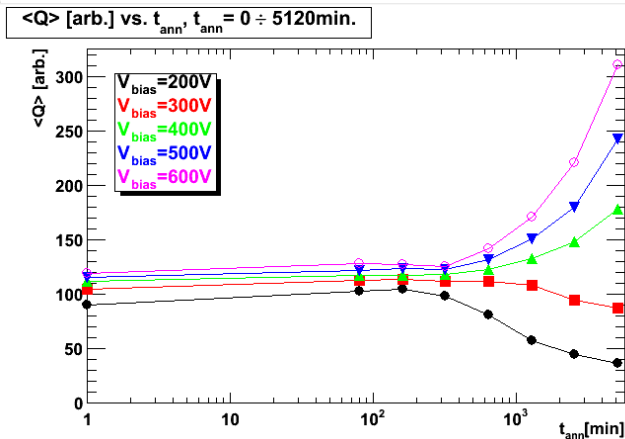
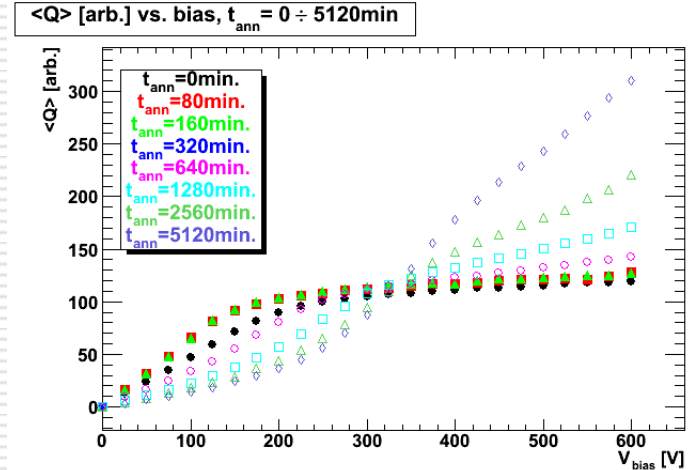
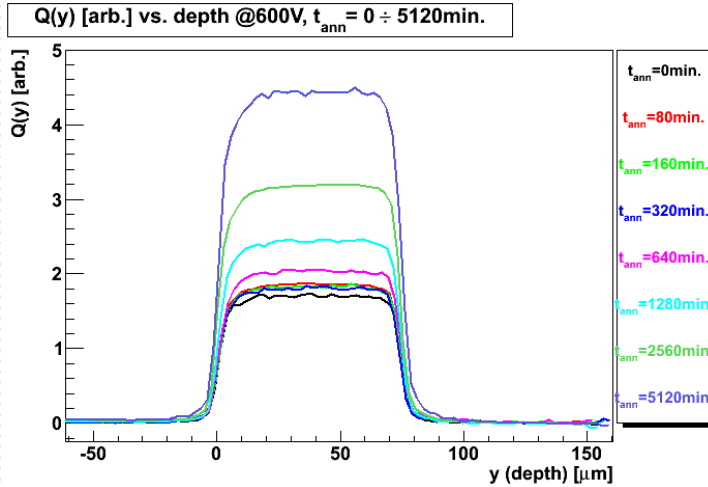


MPP/HLL - $\Phi_{eq} = 5 \cdot 10^{15}$ n/cm², HPK - $\Phi_{eq} = 1 \cdot 10^{16}$ n/cm²
 - Comparison with HPK - $\Phi_{eq} = 5 \cdot 10^{15}$ n/cm², measured with
 SCT128 by I. Mandić -



MPP/HLL – $\Phi_{eq} = 5 \cdot 10^{15} \text{ n/cm}^2$, $t_{ann} = 0 \div 20480 \text{ min}$ (75 μm)

Thanks to: Philipp Weigell and A. Macchiolo, MPI



Conclusions

- Charge collection efficiency increases with long-term annealing for highly irradiated ($\Phi_{\text{eq}} \geq 5 \cdot 10^{15} \text{ n/cm}^2$) p-type strip detectors due to increased space-charge concentration, hence the electric field in the strip region, consequently leading to the effect of multiplication even at voltages as low as a few hundred volts.
- Long term annealing shifts the multiplication mode of operation towards lower bias voltages, because it increases the space charge concentration near the n⁺-p junction.
- Even at high fluences, the detector remains active throughout the whole volume.
- The leakage current shows strong, near linear correlation with the charge multiplication.
- Measurements of Edge-TCT and SCT128 are compared and validated.

Thank you for your attention!